

## Multiple (Combinational) Deposition System



### Technical Details:

- ❖ Chamber: Spherical (or) Cylindrical with Hinged door opening
- ❖ Electrode Assembly for Evaporation Technique
- ❖ Sputtering Sources for Sputtering Technique
- ❖ Laser Sources for PLD Technique
- ❖ Ports for View, Pumping, Gas Inlet, Outlet, etc.,
- ❖ Substrate Heater with Temp. Controller
- ❖ Gas Flow Assembly with MFC and Valves
- ❖ Vacuum Gauges with digital display unit
- ❖ Gate Valve
- ❖ Vacuum Pumping System
- ❖ Digital Thickness Monitor
- ❖ Support frame with caster wheels and mobility

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